

Beamline G3 at DESY: Materials X-ray Imaging

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Why beamline G3?

- The **majority** of typical diffraction experiments determine microstructures probing larger parts of the specimen and thus **averaging** over the sample.
- But the microstructure **might vary** over the sample especially if it is of inhomogeneous composition or has been inhomogeneously processed (e.g. soldering, welding, brazing).

Why beamline G3?

Beamline G3 enables:

- **lateral resolution** of the microstructure in **direct space**,
- **visual evaluation** of *distribution* of crystal phases, *size* of crystallites, *texture* or *strain*, *structure discontinuities* like surfaces, interfaces, phase or grain boundaries.

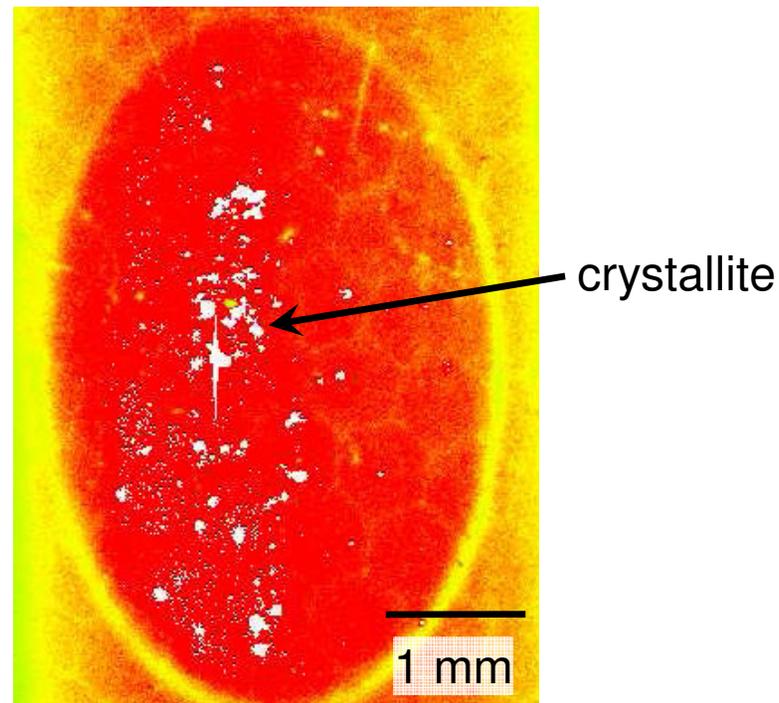


Fig. 1. Crystallites of β -Sn(312) on surface of solder joint

DORIS III at DESY

- **DORIS III:** storage ring for charged particles - positrons or electrons at an energy of 4.45 GeV, typically operates in 5 bunch mode.
- **Beam** current between 90-140 mA.
- **Synchrotron radiation** is produced in the bendings of the ring, where the insertion devices are located (wigglers, undulators, and bending magnets).
- **The spectrum** of DORIS III ranges from infrared radiation to hard X-rays, and is extreme intense particularly in the X-ray range.
- **31 beamlines.**
- **Circumference** of 289 meters.

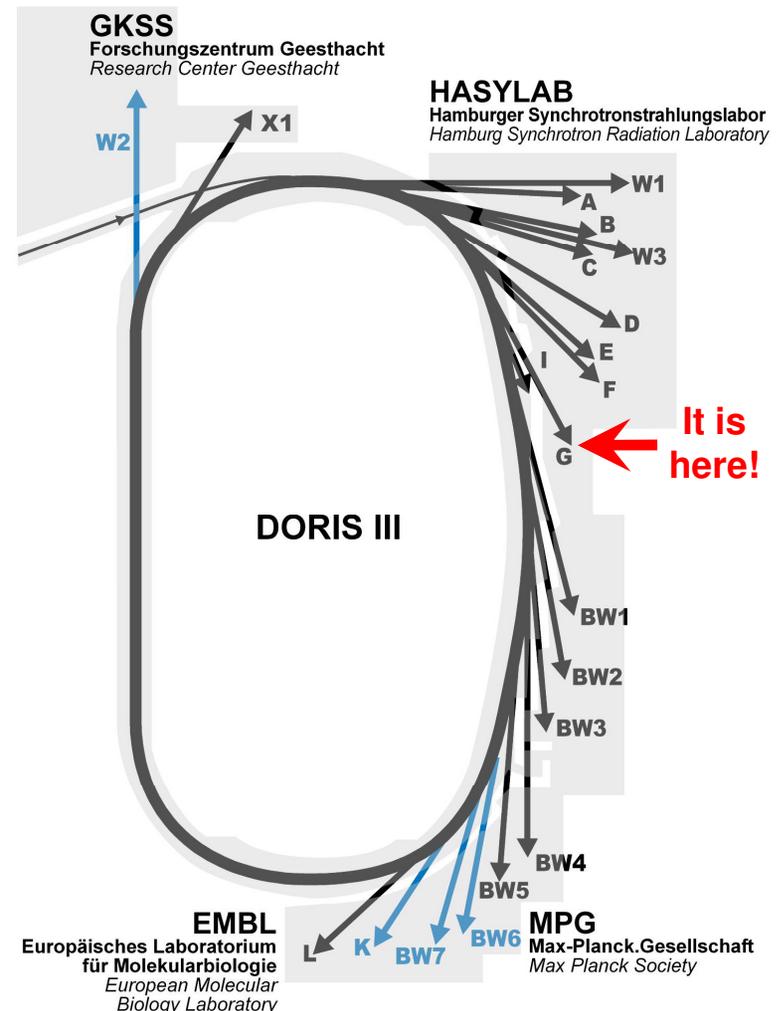


Fig. 2. DORIS III
[<http://hasylab.desy.de>]

Basic Parameters of Beamline G3

- **Monochromator:** fixed-exit double-crystal Ge (111), also further crystals available Ge (311), Si (111), Si (511), Si (400).
- **Wavelength range:** $1 \text{ \AA} < \lambda < 2.2 \text{ \AA}$ with mirror, down to 0.5 \AA without mirror (standard Ge (111) crystal).
- **Beam dimensions** at monochromator: $\sim 4 \times 16 \text{ mm}^2$.
- **Flux at the sample:** $\sim 10^8 \text{ sec}^{-1}$ (depending on monochromator crystal and chosen energy range).

Beamline G3: Experimental Station

- Monochromator, slit system, air pressure shutter, scintillation counter, gold mirror.

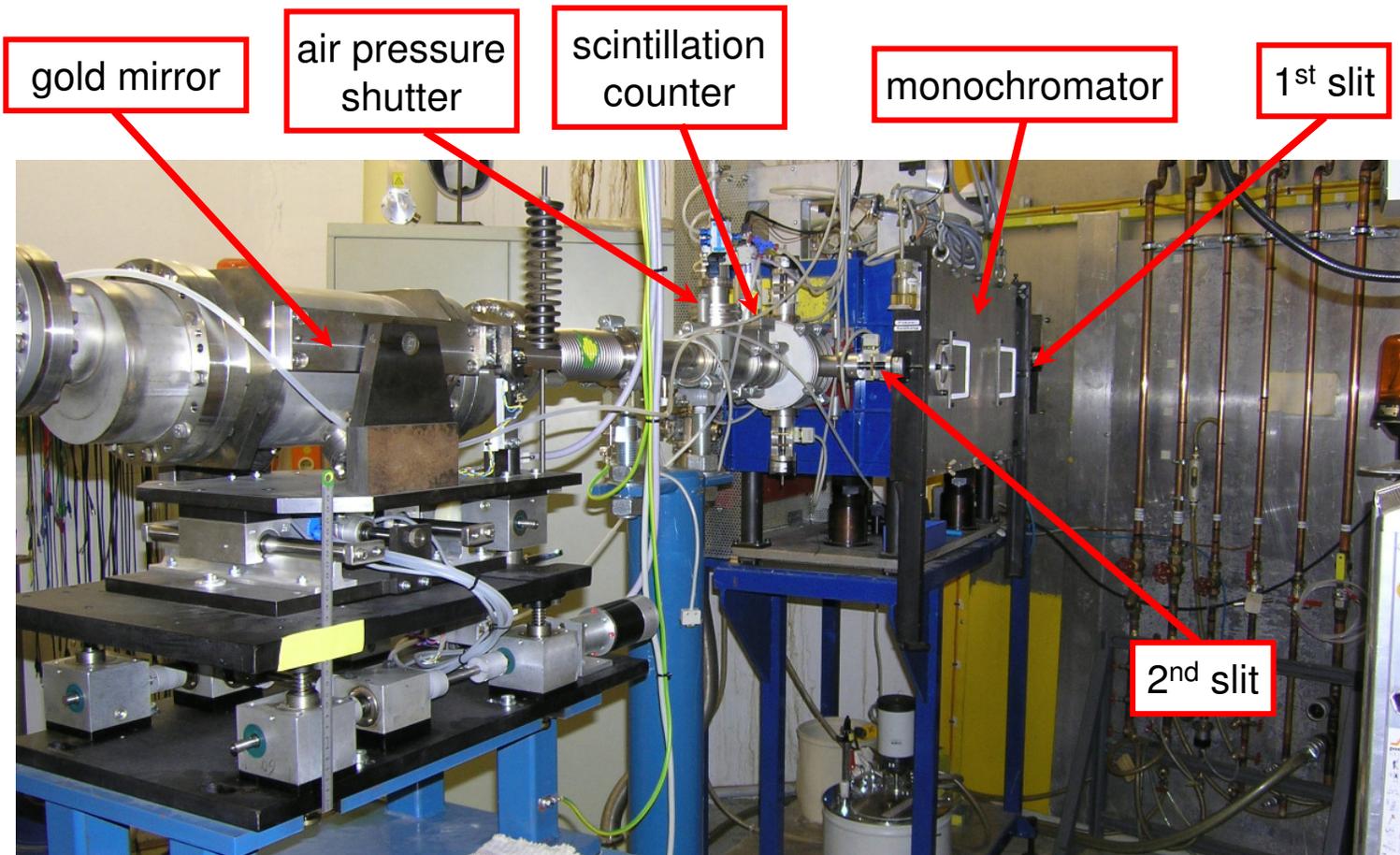


Fig. 3a. G3 experimental station
[Rothkirch]

Beamline G3: Experimental Station

- Beam tube, gold mirror, 2 detectors, 4 circle diffractometer.

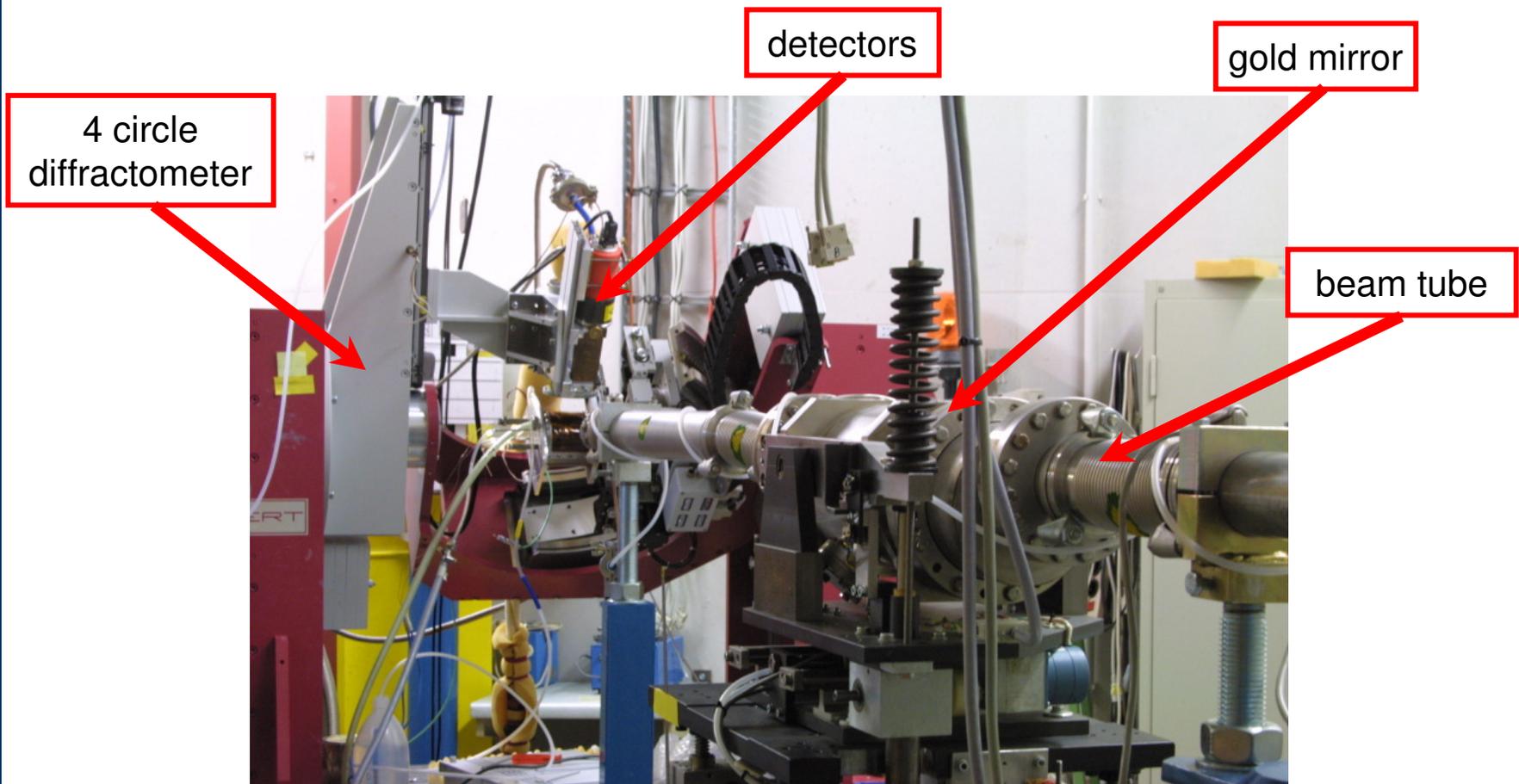


Fig. 3b. G3 experimental station
[<http://hasylab.desy.de>]

Beamline G3: Monochromator

- Fixed-exit **double-crystal** Ge (111), also further crystals available Ge (311), Si (111), Si (511), Si (400).
- All movements of the monochromator are driven by stepper motors.
- The monochromator is water cooled.
- The **tilted gold mirror** (7 mrad) is used for the suppression of higher harmonics.

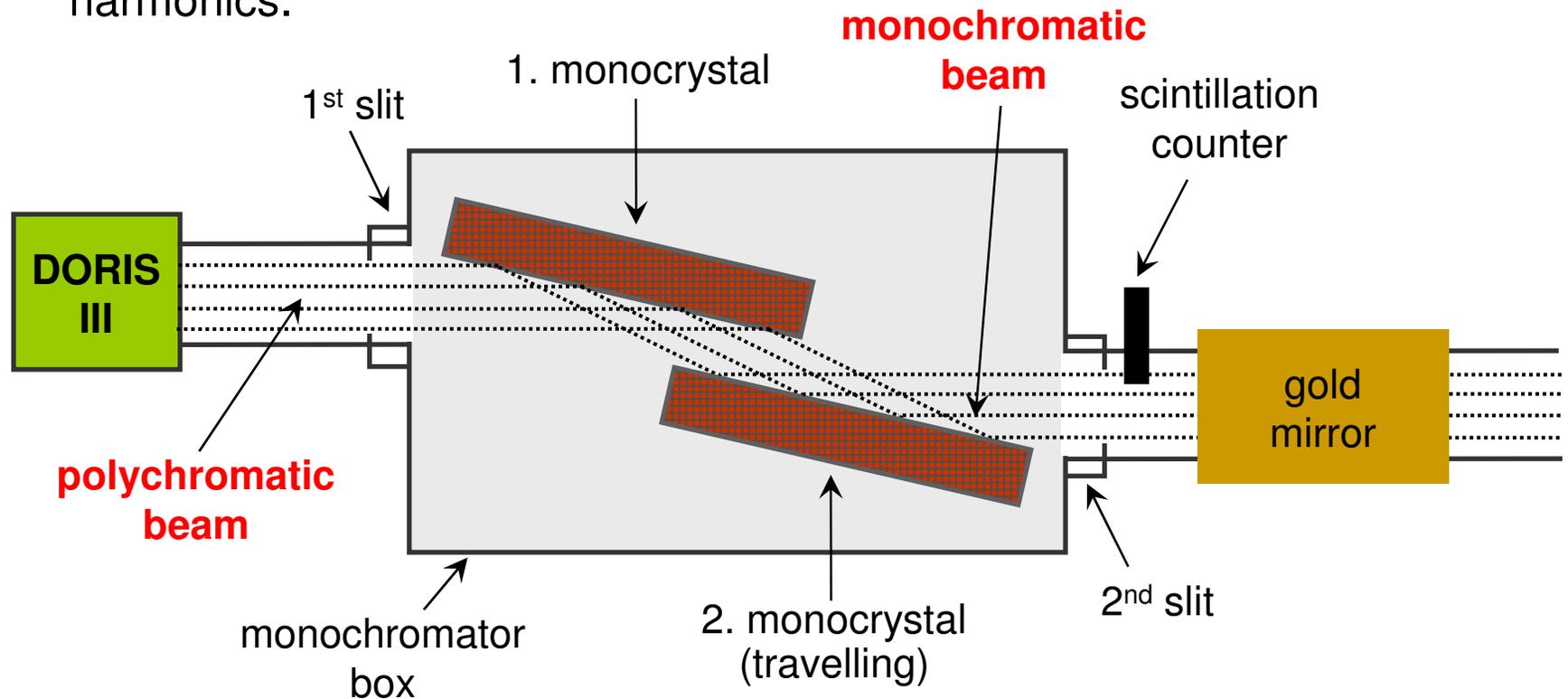


Fig. 4. G3 monochromator

Beamline G3: 4 Circle Diffractometer

- **Allows rotation** in 4 angles: 2θ , ω , φ , χ (sample tilt: $0^\circ < \chi < 90^\circ$).
- **Sample table** enables translations along x, y (± 100 mm) axes and z axis (± 10 mm).
- **A sphere** of 66 mm radius around the center of the diffractometer is free of mechanical components.
- **The detector arm** is equipped with a traverse allowing a radial translation of the detectors of up to 380 mm.
- The diffractometer holds **CCD detector with the MCP** and **point scintillation detector with Soller collimator**.

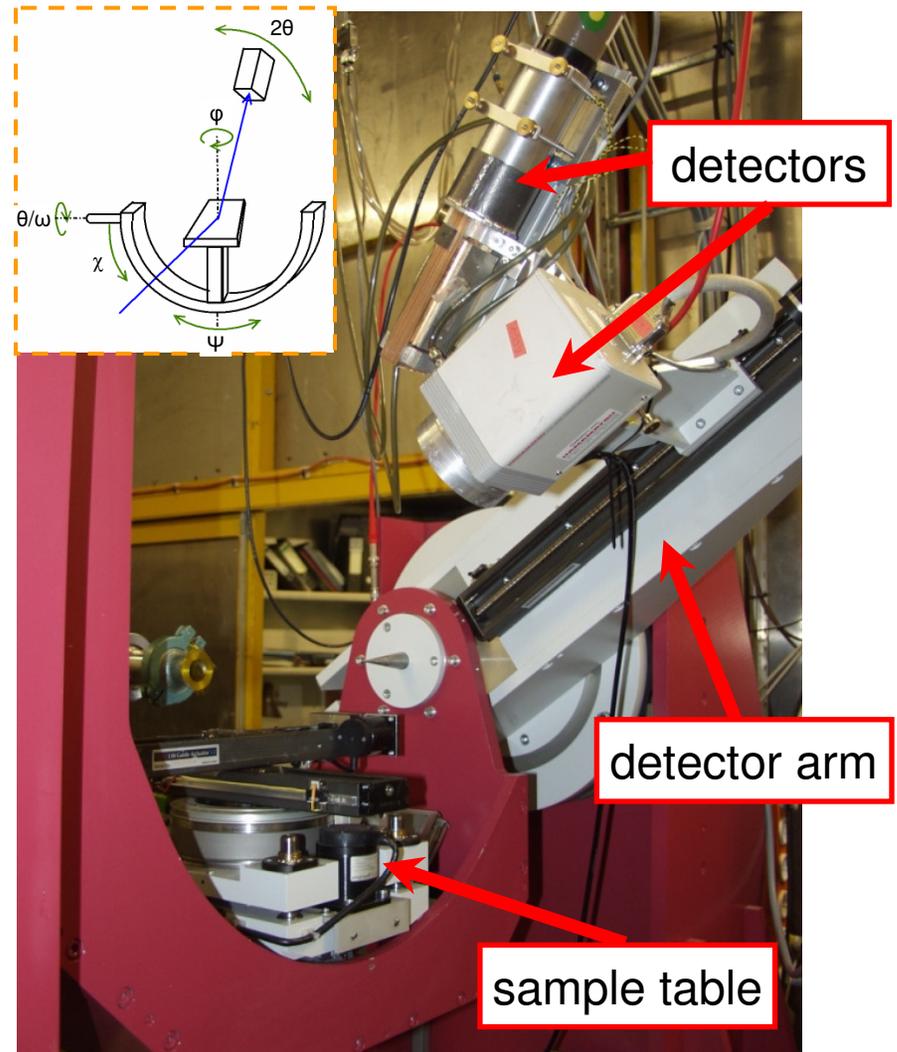


Fig. 5. 4 circle diffractometer and detectors
[<http://hasylab.desy.de>]

Beamline G3: Detectors



Fig. 5. G3 detectors
[<http://hasylab.desy.de>]

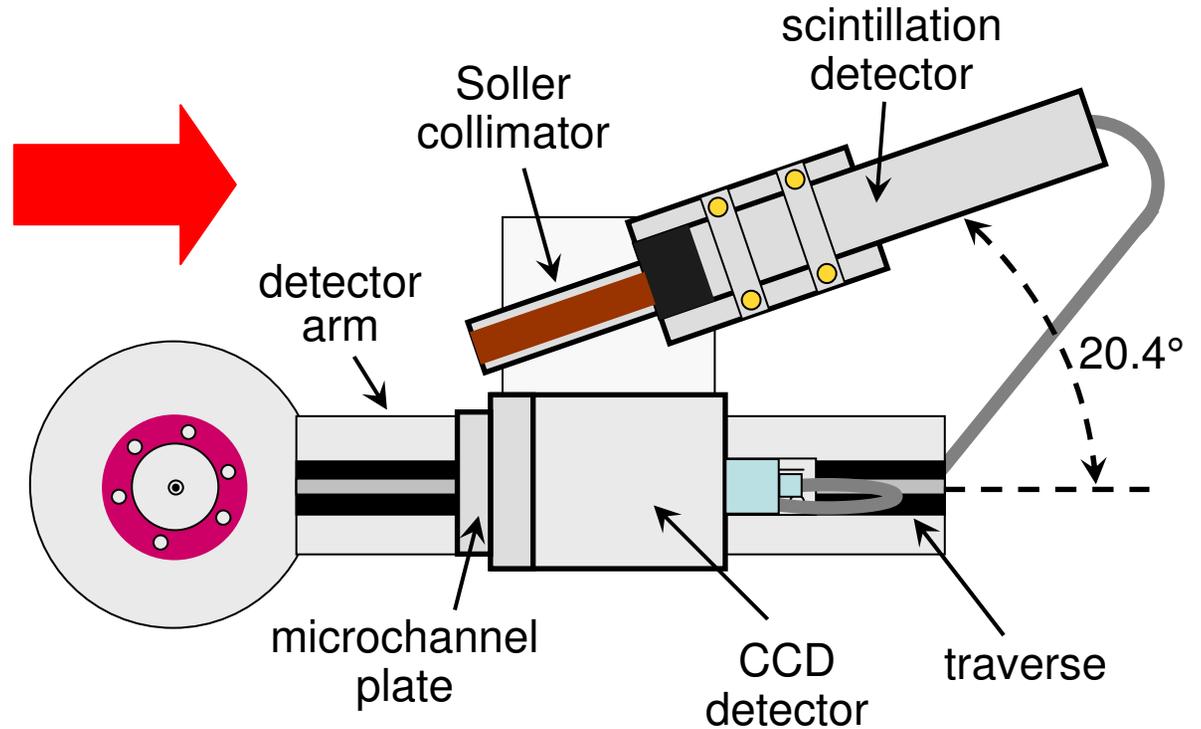


Fig. 6. Scheme of the detectors position
(side view)

- On the platform for the CCD/MCP detector, inclined by about 20.4° , a scintillation counter with Soller collimator in front is mounted.

Beamline G3: Detectors

CCD camera

- Hamamatsu 4880,
- 1024 x 1024 pixels (13 μm),
- Peltier-cooled CCD chip (-65°C),
- the MCP is in contact with capton foil of the CCD camera.

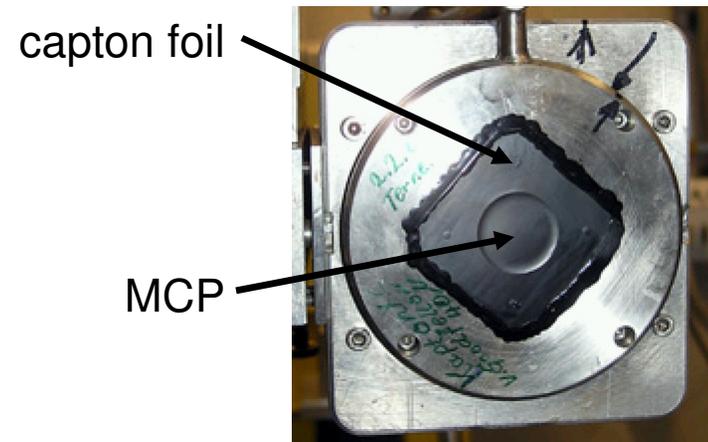


Fig. 7. CCD camera - front view
[Rothkirch]

Point scintillation detector

- Ortec LABR-1X1,
- lanthanum bromide ($\text{LaBr}_3(\text{Ce})$) detector.



Fig. 8. Scintillation detector
[www.ortec-online.com]

Beamline G3: Microchannel plate

- The microchannel plate (MCP) consists of millions of very-thin, conductive **glass capillaries** fused together and sliced into a thin plate.
- MCP is a **collimator array** between the sample and a position-sensitive detector (CCD camera).
- Each channel of the MCP acts as a collimator tube pointing to a certain location of the sample, channels arranged in **hexagonal lattice**.
- Diameter of channels is $10\ \mu\text{m}$, $12.5\ \mu\text{m}$ between their centers.

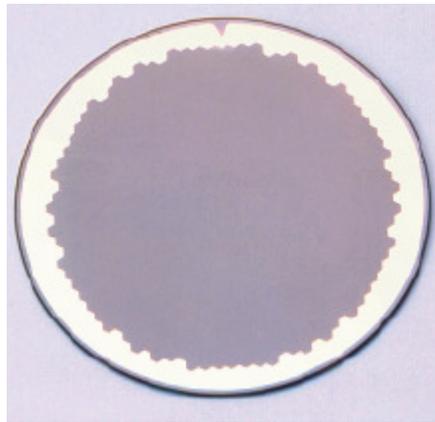


Fig. 9. Microchannel plate
(front view)
[www.hamamatsu.com]

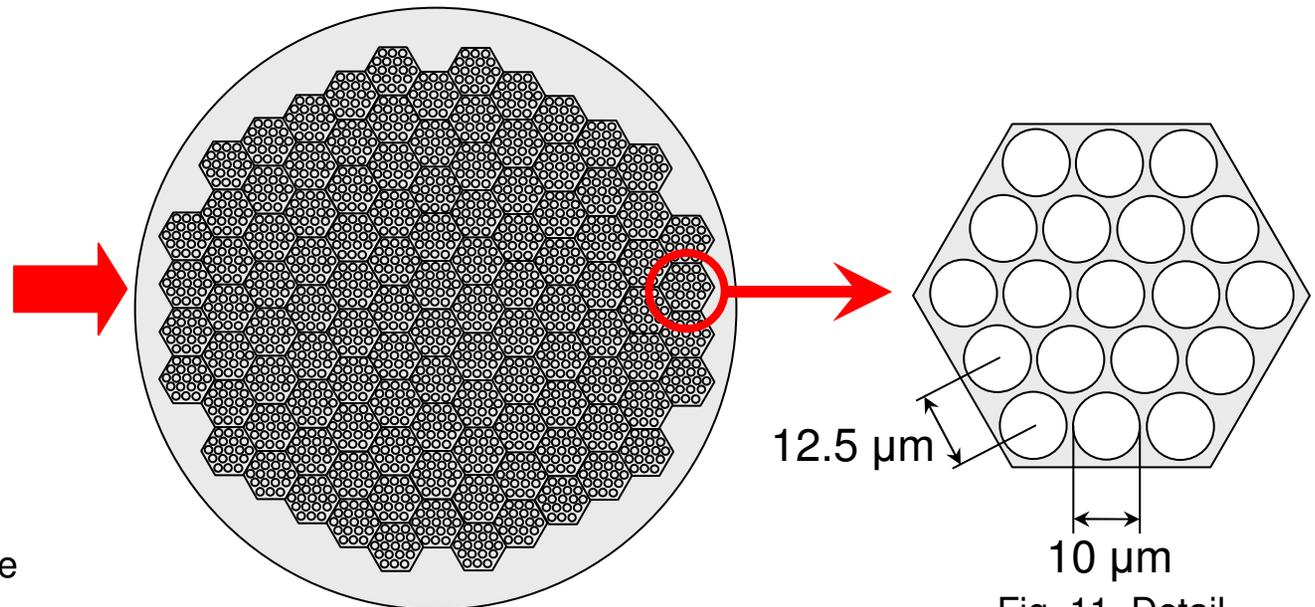


Fig. 10. Scheme of the
microchannel plate (front view)

Fig. 11. Detail
of hexagonal lattice
(front view)

Beamline G3: Microchannel plate

- The thickness of the plate is 4 mm resulting in an **angular acceptance** of 2.5 mrad full width and, considering the circular shape of the channels, a FWHM of 1 mrad.
- **Typical sample to detector distance** is 12 mm resulting in a spatial resolution of 13 μm which is also the size of each of 1024 x 1024 pixels of the CCD detector.

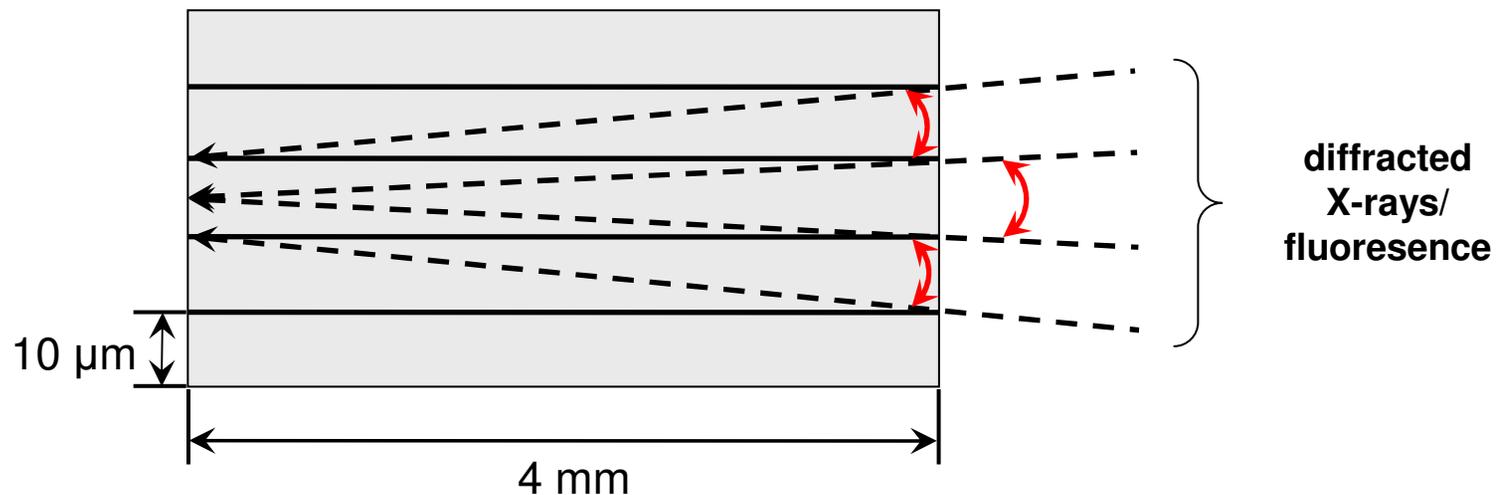


Fig. 12. Detail of hexagonal lattice
(side view)

Beamline G3: Principle of Diffraction Imaging

- Principle of diffraction imaging lies in application of the **MCP**.
- The MCP prevents detection of **crossfire** from diffracted X-rays.
- **Spatial distribution of crystal phases, ...**

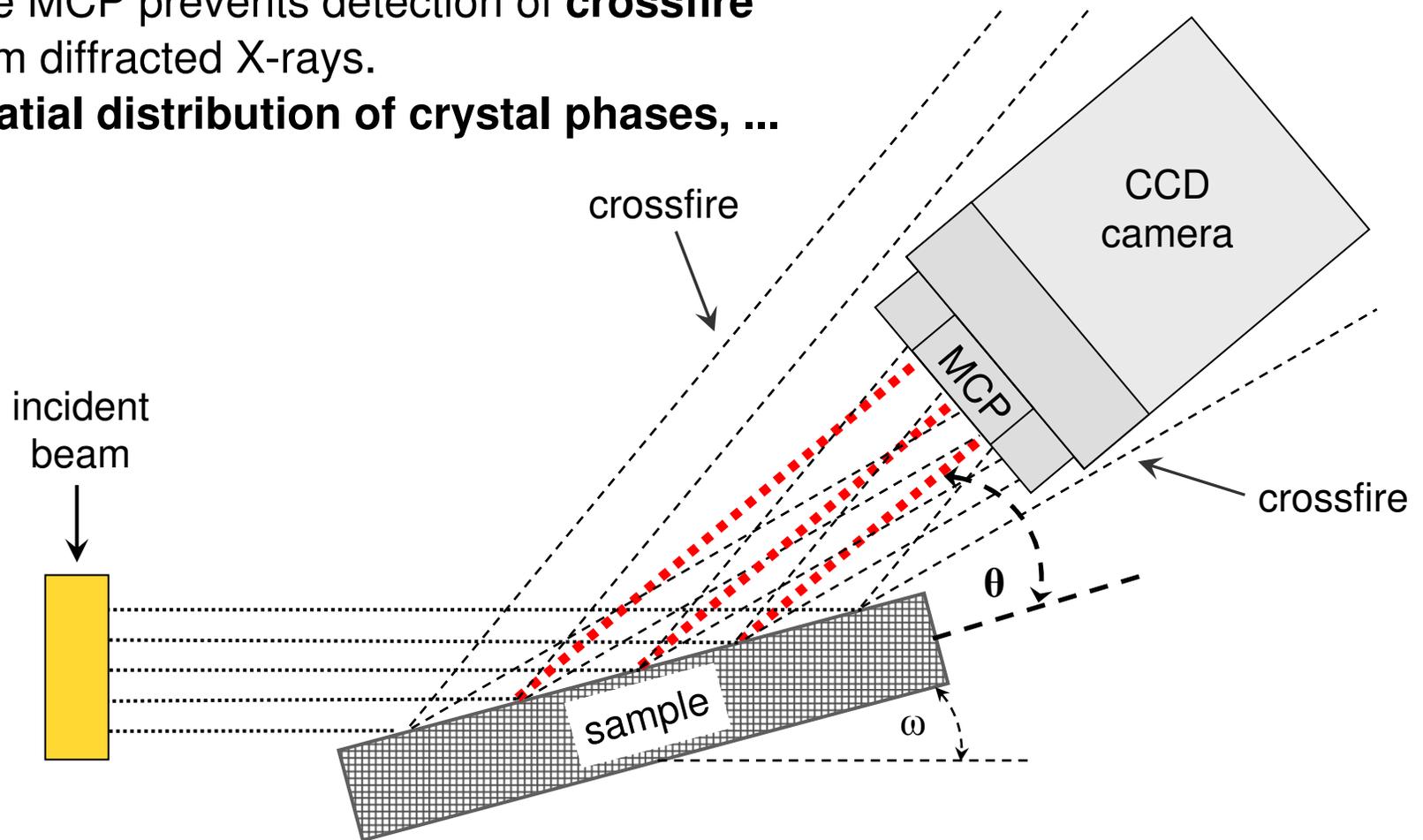


Fig. 13. Principle of diffraction imaging

Beamline G3: Principle of Fluorescence Imaging

- Variation of applied beam wavelength by crystal monochromator.
- The MCP prevents detection of “**crossfire**” from fluorescent X-rays.
- **Spatial distribution of chemical elements.**

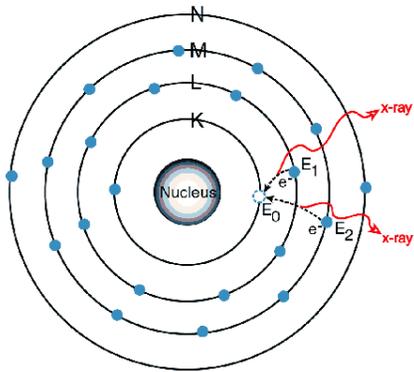


Fig. 14. Effect of fluorescence

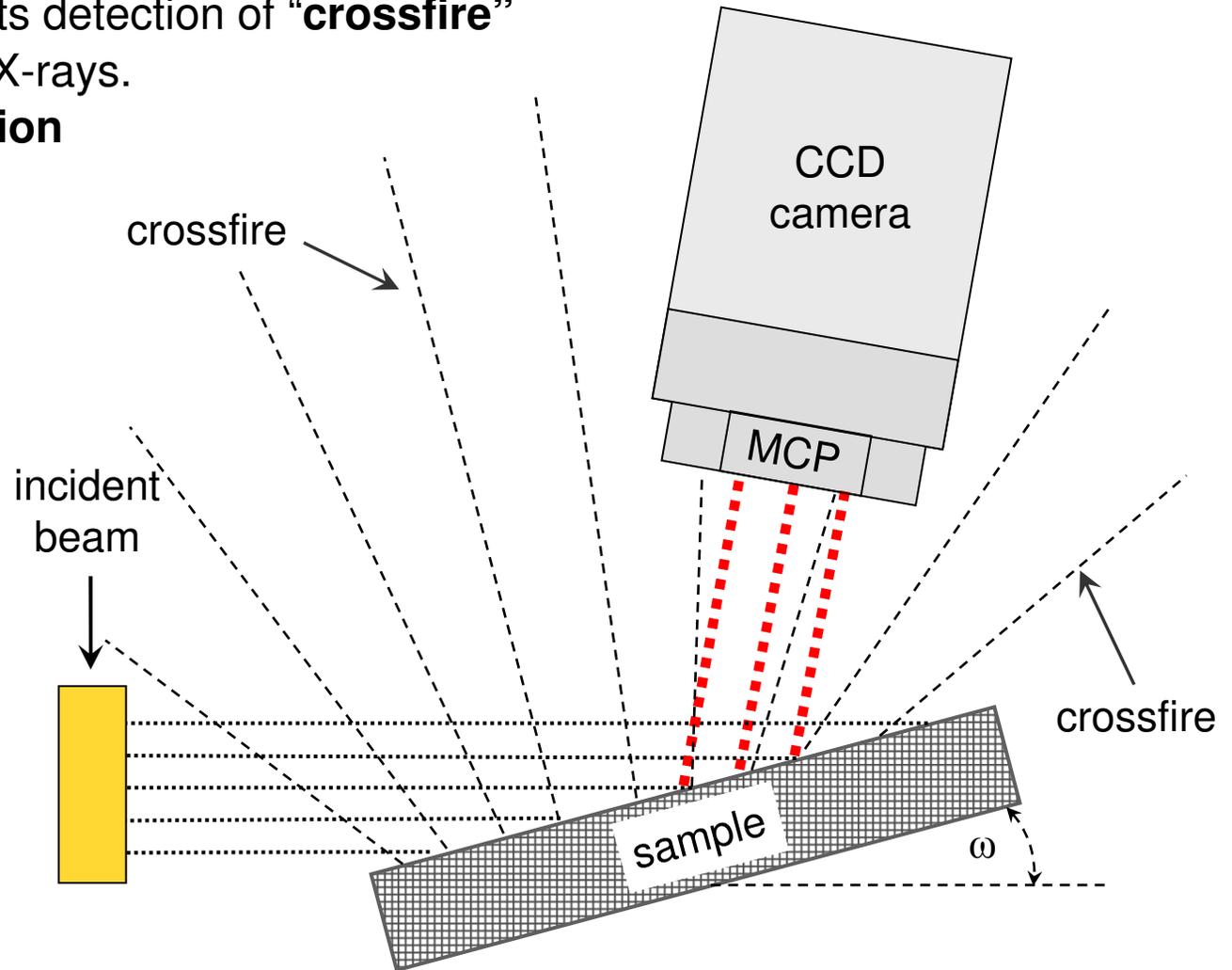


Fig. 15. Principle of fluorescence imaging

Beamline G3: Parallel polycapillaries

- Length of 300 mm, diameter of 30 μm , arranged in a hexagonal array of 8 mm distance between opposing sides.
- **Lower angular acceptance** - 30 μm / 300 mm.
- **Small angle scattering** - CCD does not move into the primary beam.
- **High energy imaging** - total reflection at the capillary walls is much less pronounced at high X-ray energies.

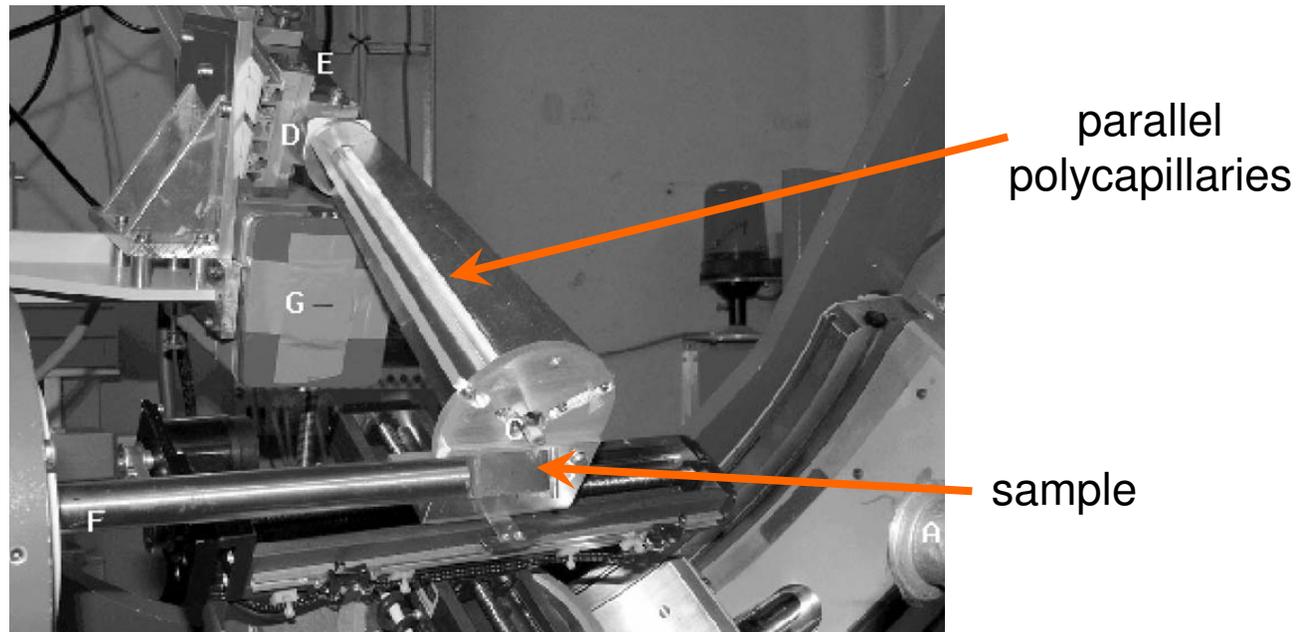


Fig. 16. Parallel polycapillaries at G3 diffractometer
[Wroblewski, Bjeoumikhov]

Beamline G3: Solid-Liquid Phase Transitions

- Includes application of **additional monocrystal Ge (111)**.
- The monocrystal enables measurements of **liquid samples**.
- Liquid samples can not be tilted.

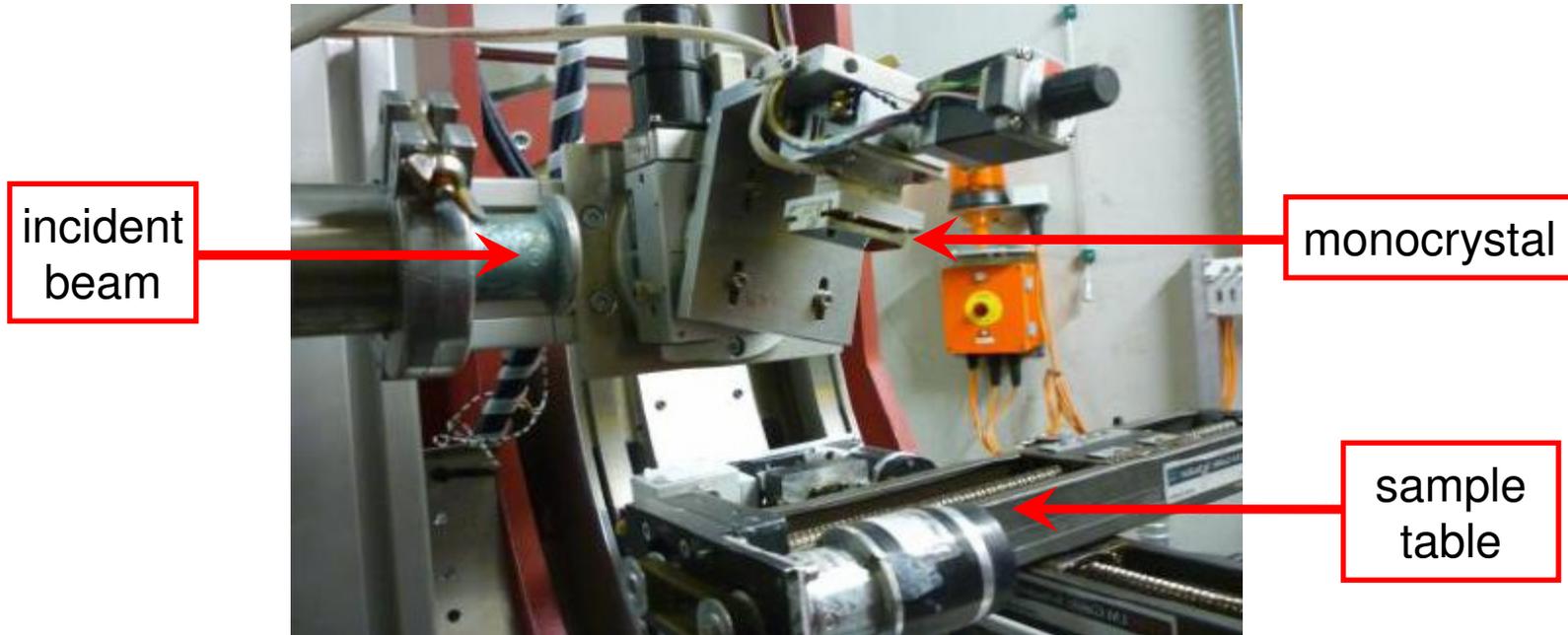


Fig. 17. Monocrystal mounted on 4 circle diffractometer
[Donges, Ovchinnikov]

Beamline G3: Solid-Liquid Phase Transitions

- Includes application of additional monocrystal Ge (111).
- **Tilt angle** of the monochromator depends on **applied wavelength**.

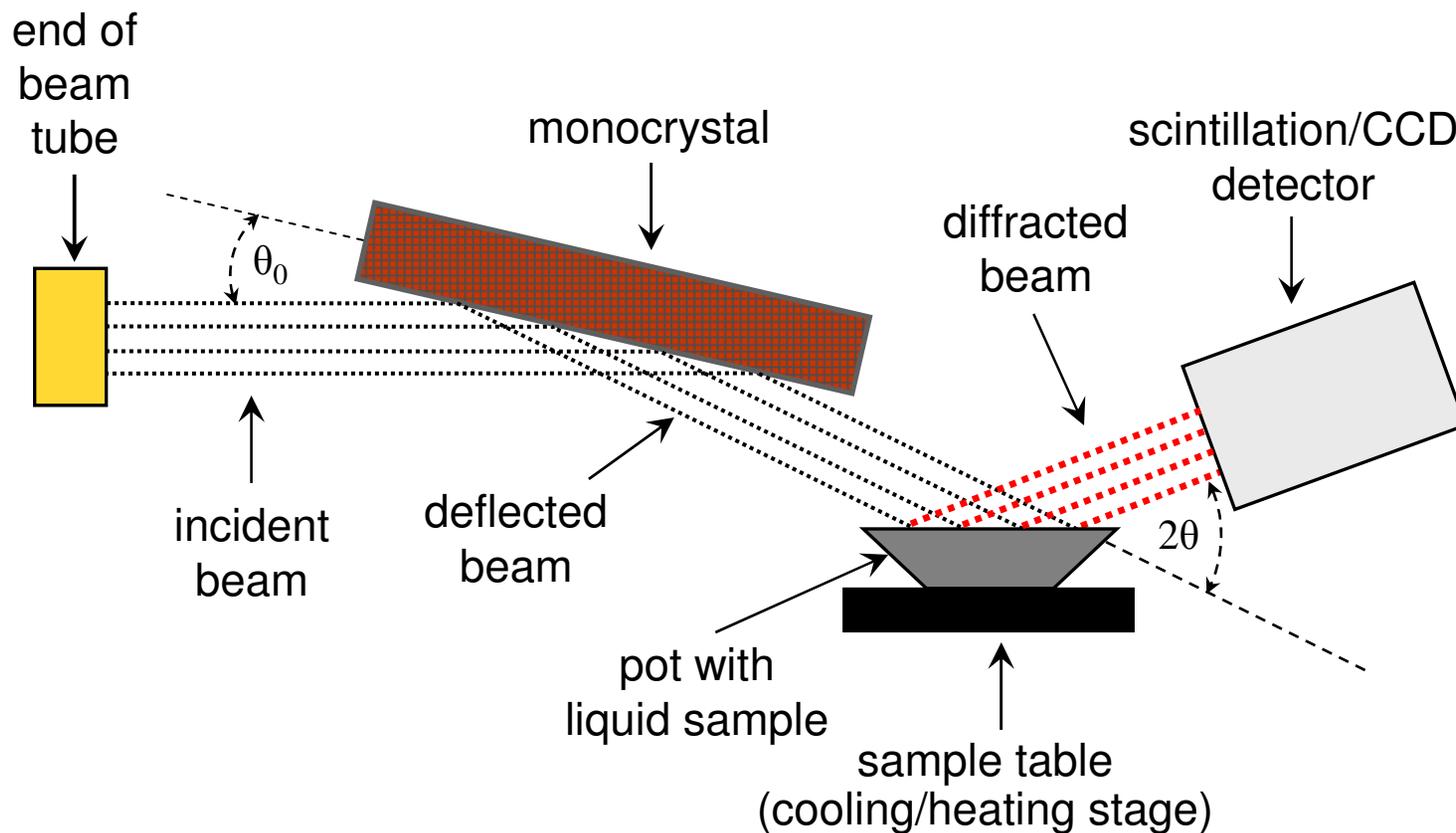


Fig. 18. Principle of liquid samples measurement

Beamline G3: Solder Alloy Measurement

- **Solder alloy:** 96.5Sn3Ag0.5Cu (wt. %).
- The alloy was soldered on copper (Cu) foil.
- **Goal of the measurement:** visualization of distribution and orientation of crystal phases of the solder (β -Sn, intermetallics – Ag_3Sn , Cu_6Sn_5) via **CCD camera**.
- Samples - **2 solder spots**.

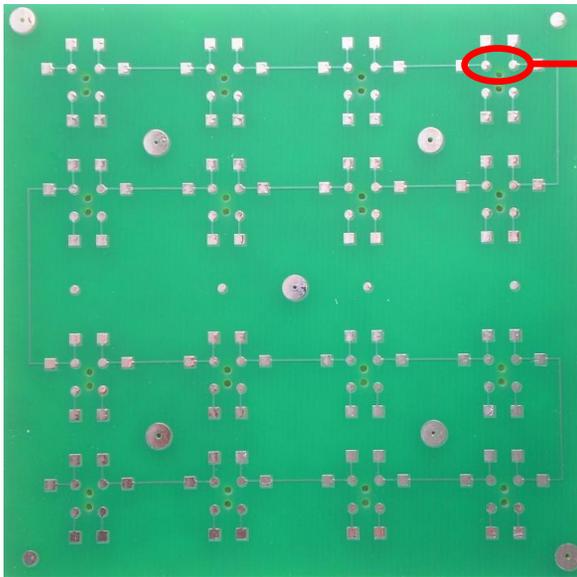


Fig. 19. PCB pattern

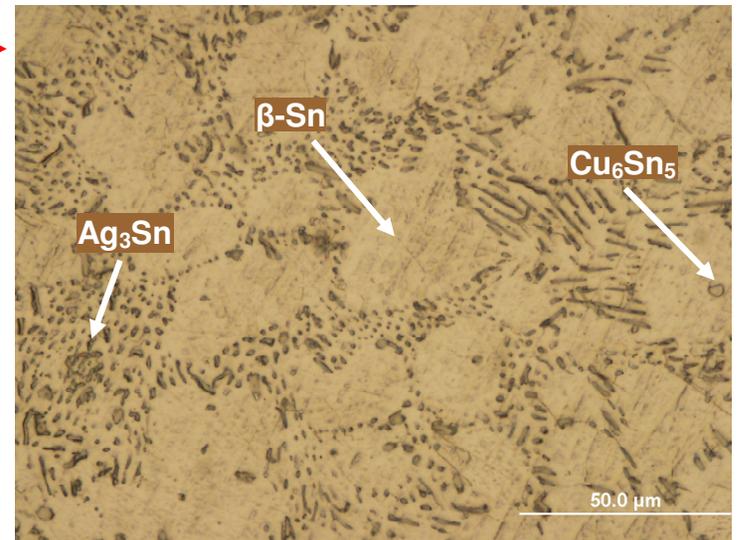


Fig. 20. Microstructure of the solder alloy [IMR SAS]

Beamline G3: Solder Alloy Measurement

1. step

- point scintillation detector,
- **Bragg-Brentano geometry,**
- 2θ range: 30° - 105° , $\Delta 2\theta=0.04^\circ$, $\lambda = 1.54187 \text{ \AA}$ (Cu K_{alpha}),
- the solder spots positioned on the sample table of 4 circle diffractometer,
- **Time reduction of CCD camera measurement.**

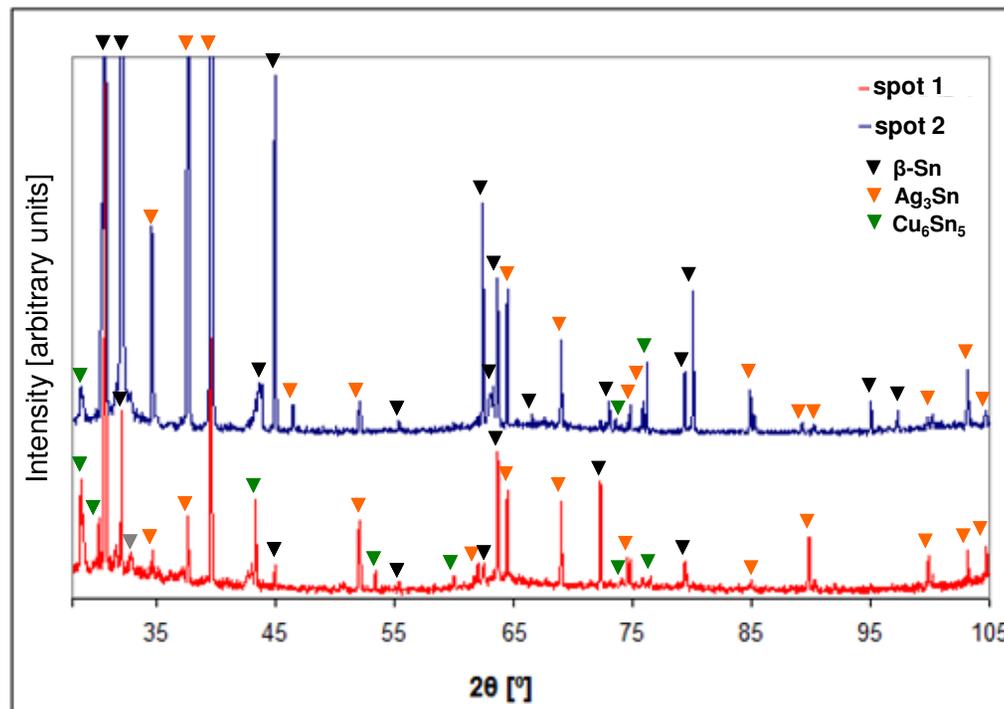


Fig. 21. Diffraction patterns of 2 solder spots

Beamline G3: Solder Alloy Measurement

2. step

- CCD camera (detector),
- $\lambda = 1.54187 \text{ \AA}$ (Cu K_{alpha}),
- 2θ range selection: $2\theta=60-100^\circ$, but measured was only in limit of **width of Bragg peaks at their basis**,
- $\Delta 2\theta=0.04^\circ \approx 300$ seconds.

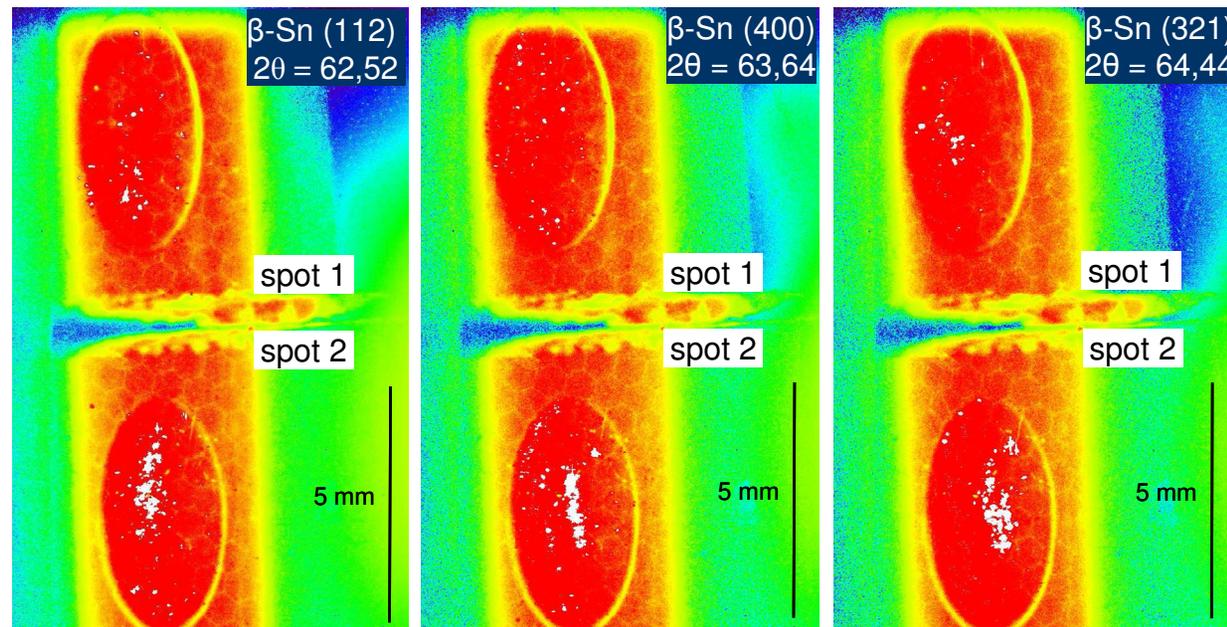


Fig. 22. Diffraction imaging of solder spots at selected angles

Beamline G3: Solder Alloy Measurement

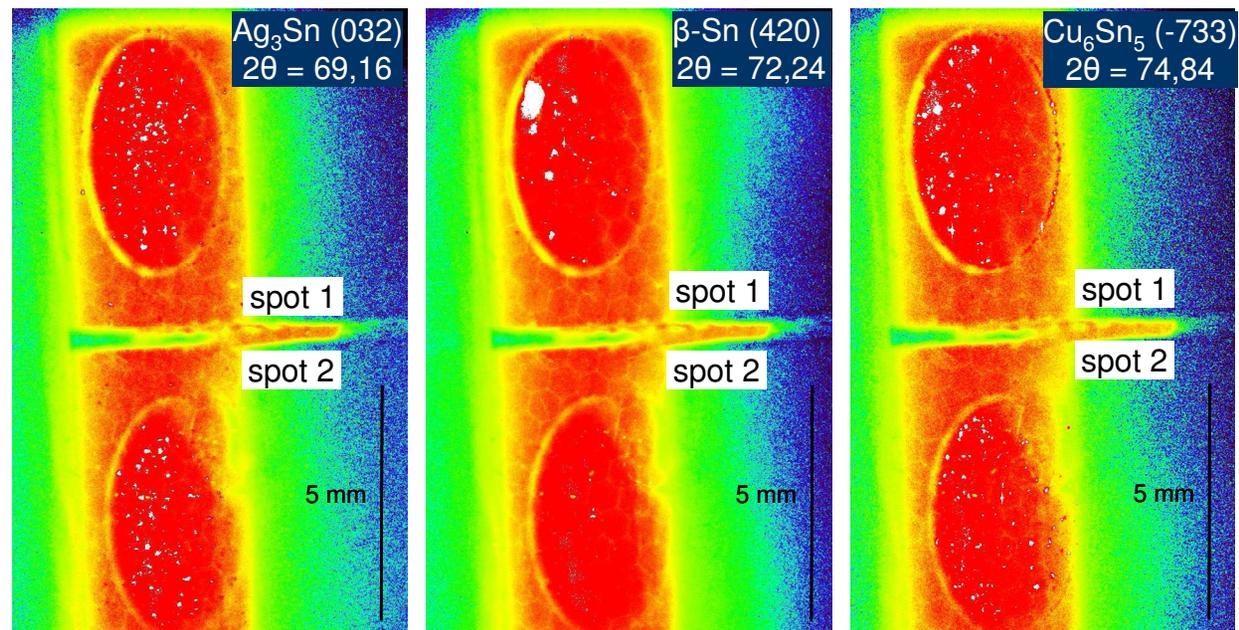


Fig. 23. Diffraction imaging of solder spots at selected angles

Beamline G3: Solder Alloy Measurement

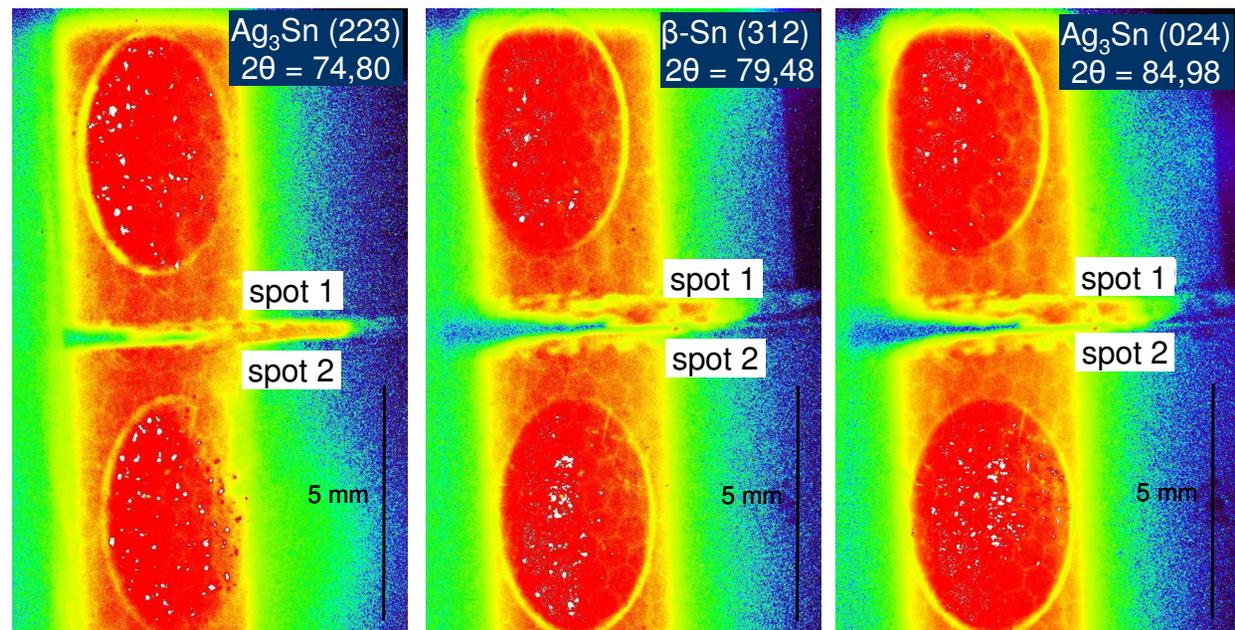


Fig. 24. Diffraction imaging of solder spots at selected angles

Beamline G3: Solder Alloy Measurement

Brief summary

- **Non-uniform distribution** of β -Sn crystals (if crystal orientation taken into consideration),
- size of β -Sn crystals: $\approx 10^1$ - 10^2 μm ,
- **uniform distribution** of intermetallics – Ag_3Sn , Cu_6Sn_5 .

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